

<b>Notice of References Cited</b>	Application/Control No. 10/809,914	Applicant(s)/Patent Under Reexamination KATHMAN ET AL.	
	Examiner Kianni C. Kaveh	Art Unit 2883	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0002809	01-2003	Jian, Benjamin B.	385/73
*	B	US-6,981,804	01-2006	Jian, Benjamin B.	385/88
*	C	US-6,606,011	08-2003	Anthony et al.	333/12
*	D	US-6,509,807	01-2003	Anthony et al.	333/12
*	E	US-2003/0162214	08-2003	Heller et al.	435/6
*	F	US-2002/0068373	06-2002	Lo et al.	438/33
*	G	US-6,597,713	07-2003	Ouchi, Toshihiko	372/36
*	H	US-6,184,066	02-2001	Chino et al.	438/118
*	I	US-6,104,690	08-2000	Feldman et al.	369/112.26
*	J	US-4,873,566	10-1989	Hokanson et al.	257/98
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.